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<b>SERIAL NUMBER</b> 10/602,878	<b>FILING OR 371(c) DATE</b> 06/25/2003 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> 60188-538
<b>APPLICANTS</b> Hideo Oishi, Osaka, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a DIV of 09/905,922 07/17/2001 PAT 6,603,316				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2000-215312 07/17/2000				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 04/09/2004</b>				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged _____ Examiner's Signature _____ Initials _____		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 13	<b>TOTAL CLAIMS</b> 7
<b>INDEPENDENT CLAIMS</b> 3				
<b>ADDRESS</b> 20277				
<b>TITLE</b> SEMICONDUCTOR WAFER TEST SYSTEM				
<b>FILING FEE RECEIVED</b> 1050	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	